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Masakazu Baba, Tokyo, JAPAN; Toru Sano, Tokyo, JAPAN; Kazuhiro Uda, Tokyo, JAPAN; Hisao Kawaura, Tokyo, JAPAN; Noriyuki Iguchi, Tokyo, JAPAN; Wataru Hattori, Tokyo, JAPAN; Hiroko Someya, Tokyo, JAPAN; Minoru Asogawa, Tokyo, JAPAN; This application is a 371 of PCT/JP03/15252 11/28/2003 ** FOREIGN APPLICATIONS ************************************						
Foreign Priority claimed		DRAWING CLAI		MS	INDEPENDENT CLAIMS 2	
ADDRESS 23373						
TITLE Sample drying device as well as mass spectrometer and mass spectrometry system therewith						
FEE FEES: Authority has been given in Paper VED No to charge/credit DEPOSIT ACCOUNT 0 No for following:			All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other			
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